AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

LISTING OF CLAIMS:

- 1. (Currently Amended) A high emissivity radiator comprising a substrate, an amorphous carbon layer formed on a radiating surface of the substrate, and a metallic earbide-forming carbide layer interposed between the substrate and the amorphous carbon layer and a protective layer formed on the amorphous carbon layer.
- 2. (Currently Amended) The radiator of claim 1, wherein the metallic carbide-forming carbide layer comprises titanium.
- 3. (Currently Amended) The radiator of claim 1, wherein the amorphous carbon layer and/or the titanium carbide layer has a thickness in the range of 0.1 micrometres to 1.0 micrometres.
 - 4. (Cancelled).
- 5. (Currently Amended) The radiator of claim [[4]] 1, wherein the protective layer is substantially transparent to infrared radiation.

- 6. (Previously Presented) The radiator of claim 5, wherein the protective layer comprises at least one of SiC, SiO₂, diamond and diamond-like carbon.
- 7. (Currently Amended) A method of making a radiator <u>having an</u>

 <u>emissivity of at least 30% for radiation of wavelength in the range of 3µm to 5µm, the</u>

 <u>method</u> comprising the steps <u>of forming of:</u>

providing a substrate having a radiating surface; forming a metallic carbideforming layer on a substrate the radiating surface; [[and]]

forming an amorphous carbon layer on <u>and in contact with</u> the metallic carbide-forming layer; <u>and</u>

forming a protective layer on the amorphous carbon layer.

- 8. (Original) The method of claim 7, wherein the amorphous carbon layer and/or the metallic carbide forming layer is formed by sputter deposition or evaporation.
 - 9. (Cancelled).
- 10. (Currently Amended) The method of claim [[7]] 1, wherein the radiator is annealed after the steps of forming the metallic carbide-forming and amorphous carbon layers.
 - 11. (Cancelled)

- 12. (Cancelled)
- 13. (Currently Amended) A radiator comprising: a substrate[[,]]; a soft amorphous carbon layer formed on the substrate; and

a metallic carbide layer interposed between the substrate and the amorphous carbon layer layer, wherein the metallic carbide layer is in contact with the amorphous carbon layer.

- 14. (Previously Presented) The radiator of claim 13, being a high emissivity radiator.
- 15. (Previously Presented) The radiator of claim 13 wherein the amorphous carbon layer is an annealed amorphous carbon layer.
- 16. (Currently Amended) A method of making a radiator comprising the steps of providing a metallic carbide-forming layer on a substrate; and forming a soft amorphous carbon layer on and in contact with the metallic carbide-forming layer.
- 17. (Previously Presented) The method of claim 16 wherein the radiator is a high-emissivity radiator.
- 18. (Currently Amended) The method of claim 16 wherein the metallic carbide-forming layer is provided <u>as</u> [[on]] an integral surface layer of the substrate.

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- 19. (Previously Presented) The method of claim 16 wherein the metallic carbide-forming layer is provided as a separate layer on a surface of the substrate.
- 20. (Currently Amended) The radiator of claim 2, wherein the amorphous carbon layer and/or the titanium carbide layer has a thickness in the range of 0.1 micrometres to 1.0 micrometres.
 - 21. (Cancelled).
- 22. (Currently Amended) The radiator of claim [[2]] 13, wherein the amorphous carbon carbide layer is protected by a protective layer comprises titanium.
- 23. (Currently Amended) The method of claim [[8]] 7, wherein the radiator is annealed after the steps of forming the metallic carbide-forming and amorphous carbon [[layers]] layer.
- 24. (Currently Amended) The method of claim [[9]] 16, wherein the radiator is annealed after the steps of forming the metallic carbide-forming and amorphous carbon [[layers]] layer.
- 25. (New) The radiator of claim 1, wherein the radiator has an emissivity of at least 30% for radiation of wavelength in the range of $3\mu m$ to $5\mu m$.